LIA
THE LASER INSTITUTE

WILLIAM M. STEEN AWARD

In furtherance of our vision, “to foster lasers, laser applications, and laser safety, worldwide,” The Laser Institute (LIA®) has the distinct honor and privilege of presenting the William M. Steen Award to institutions (as defined in Eligibility) that have shown significant contribution in the area of laser material processing. For the purposes of this nomination, “lasers” may include traditional or new lasers, light-emitting diodes, and other high-intensity light sources.

Objective

Named after an early pioneer in the subject, the William M. Steen Award is annually conferred to a single institution that has successfully demonstrated a significant and innovative development in laser material processing.

Laser Material Processing represents a significant area of growth in modern manufacturing. The LIA established this award to highlight and advocate for the incredible potential of this area of engineering. Adjudicated by a distinguished panel of laser industry leaders and pioneers, this award recognizes institutions that have and are making achievements in this technology.

Eligibility

To qualify for the William M. Steen Award, the recipient shall be an institution – a legal entity including but not limited to commercial and non-commercial businesses, academic and research institutions, and government agencies. Further, the innovative development shall fit at least one of the following criteria:

- Application of lasers to a new area (e.g., manufacturing, materials processing, fusion, quantum technology, quantum computing).
- Solution to a long-standing problem, either particular or general, using lasers.
- Novel application of lasers in medicine, agriculture, and other fields of broader impact.
- Development of sensors and detectors for laser diagnostics, monitoring of laser processes, and other related applications such as laser probing of physical, chemical, and biological processes.

Nature of the Award

The William M. Steen Award is conferred annually at the International Congress on Applications of Lasers and Electro-Optics (ICALEO®) Awards Ceremony. Upon acceptance of the award, the recipient institution will be granted:

- One complimentary full conference registration to ICALEO.
- An aural presentation of the award citation at the ICALEO Awards Ceremony.
- A ten-minute presentation allocation at the ICALEO Awards Ceremony, customarily given by a C-level executive of the recipient institution

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12001 Research Parkway, Suite 210, Orlando, FL 32826

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WILLIAM M. STEEN AWARD NOMINATION

NOMINATOR INFORMATION

Nominator Name: _____

Nominator Affiliation: _____

Nominator Email: _____

Nominator Telephone: _____

How long have you been aware of the institution's accomplishments related to this nomination?

_____

NOMINEE INFORMATION

Nominee - Institution Name: _____

Nominee - Institution Address: _____

Nominee - Contact Name: _____

Nominee - Contact Email: _____

Nominee - Contact Telephone: _____

Title of Nominee Product, Technology, or Category: _____

Brief synopsis of the Novelty of the Subject Product or Technology (Maximum 400 words)

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Brief synopsis cont.

Primary assertion explaining how the nominee's product or technology satisfies the award eligibility criteria, as outlined above.

PLEASE EMAIL or MAIL YOUR COMPLETED FORM TO:

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